

JUN 23, 2004

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TO: OFFICE OF PATENT PUBLICATIONS DATE: JUNE 23, 2004

COMPANY: U.S. PATENT AND TRADEMARK OFFICE

FROM: EUGENE M. LEE, REG. NO. 32,039

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OUR REFERENCE NUMBER: 249/275

In re the Application of:

Notice of Allowance Mailed:
March 25, 2004

Jeong-sic JEON, et al.

Art Unit: 1763

Serial No. 10/003,412

Examiner: Parviz HASSANZADEH

Filed: December 6, 2001

Confirmation No. 5396

For: APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE

Transmitted herewith is/are

► AMENDMENT UNDER 37 C.F.R. §1.312

Return receipt, via facsimile [to 703.525.4265], of the above-referenced document(s) is hereby requested.

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Attorney Docket No. 249/275

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Commissioner for Patents

United States Patent and Trademark Office

Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENT

It is respectfully requested that the above-referenced application be returned to the Examiner for consideration and entry of the following amendment:

IN THE SPECIFICATION

Kindly amend the specification as follows:

Page 13, paragraph [0035]

[0035] For a wafer 30 shown in Fig. 1A having a diameter identical to the diameter M3 of the wafer 130 shown in Fig. 2, the diameter M1 of the insulating plate 120 shown in Fig. 2 would preferably be larger than the diameter L1 of an insulating plate 20 in Fig. 1A 2. Thus, the distance spanned by the plurality of induction coils 114 shown in Fig. 2 would be greater than distance spanned by the plurality of induction coils 14 shown in Fig. 1A.